

Attorney Docket No. 03663/LH

This paper is being submitted
via EFS-Web on December 15, 2006

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): Tomio MATSUZAKI et al

Serial No. : 10/700,136

Conf. No. : 3722

Filed : November 3, 2003

For : WIRING STRUCTURE ON
SEMICONDUCTOR SUBSTRATE
AND METHOD OF FABRICATING
THE SAME

Art Unit : 2811

Examiner : Steven Ho Yin Loke

In the event that this Paper is late filed, and the necessary petition for extension of time is not filed concurrently herewith, please consider this as a Petition for the requisite extension of time, and to the extent not already paid, authorization to charge the extension fee to Account No. 06-1378. In addition, authorization is hereby given to charge any fees for which payment has not been submitted, or to credit any overpayments, to Account No. 06-1378.

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R:

Applicants hereby petition for a one (1) month extension of time for timely filing of the papers filed concurrently herewith.

Extended time expires December 15, 2006.

The Patent Office fee of \$1020.00 is being paid by credit card herewith. If any further fees are required, authorization is given to charge same against Account No. 06-1378.

Respectfully submitted,

/Douglas Holtz/

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